

JUL 26 2005

2771-605

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

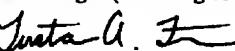
In re United States Patent Application of:	}	Docket No.:	2771-605 (7486)	
Applicants:	ROEDER, Jeffrey F. et al.	}	Conf. No.:	3324
Application No.:	10/643,110	}	Art Unit:	2891
Date Filed:	August 18, 2003	}	Examiner:	Caridad Everhart
Title: PRECURSOR COMPOSITIONS AND PROCESSES FOR MOCVD OF BARRIER MATERIALS IN SEMICONDUCTOR MANUFACTURING		}	Customer No.:	25559

FACSIMILE TRANSMISSION CERTIFICATE
 ATTN: Examiner Caridad Everhart
 Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 26, 2005, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pages (including cover)



Tristan A. Fuierer

July 26, 2005

Date

RESPONSE TO MAY 2, 2005 OFFICE ACTION IN U.S. PATENT APPLICATION NO.
10/643,110

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, Virginia 22313-1450

Sir:

This responds to the May 2, 2005 Office Action in the above-identified application.

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Please amend the application as set out in the following **Section I** (Amendment of the Claims).

Remarks addressing the substance of the May 2, 2005 Office Action are set out in **Section II** (Remarks) hereof.